

UNITED STATES DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

---

Inventors: HE, Ting et al.  
Serial Number: 10/757,302  
Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM  
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit: 1763  
Examiner: Richard R. Bueker

Atty. Docket No.: 3994994-148069      CONFIRMATION NO. 4457

---

**Amendment and Response to Office Action Mailed on June 25, 2010**

*By E-file [registered user]* on SEPTEMBER 27, 2010  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

To the Honorable Commissioner:

In response To the Office Action Mailed on June 25, 2010, entry of this amendment, reexamination and reconsideration is requested.

1) Amendments to the Claims begin on page 2; and

3) Remarks begin on page 7.

///